



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Crocifisso Marco Antonio RENNA, Luigi LA MAGNA, Simona LORENTI, and Salvatore COFFA

Title: MANUFACTURING METHOD FOR A SEMICONDUCTOR SUBSTRATE COMPRISING AT LEAST A BURIED CAVITY AND DEVICES FORMED WITH THIS METHOD

Serial Number: 10/726,005

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Examiner/Unit: Monica D. Harrison / 2812

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CERTIFICATE OF MAILING OR TRANSMISSION

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Signature

**AMENDMENT AND RESPONSE UNDER 37 CFR §1.111**

TO THE COMMISSIONER FOR PATENTS

Please reconsider the above-referenced patent application in view of the following amendments and remarks:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.